



IFW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masaru MITSUI

Application No.: 10/523,470

Filed: March 10, 2005

Docket No.: 122672

For: METHOD FOR MANUFACTURING MASK BLANK, METHOD FOR
MANUFACTURING TRANSFER MASK, SPUTTERING TARGET FOR
MANUFACTURING MASK BLANK

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please consider the following:

Amendments to the Specification;

Remarks.